



SYSTEM FOR ELECTROPOLISHING AND ELECTROCHEMICAL
MECHANICAL POLISHING

Basol et al.

Appl. No.: 10/822,424 Atty Docket: ASMNUT.029CP*

DIVISION

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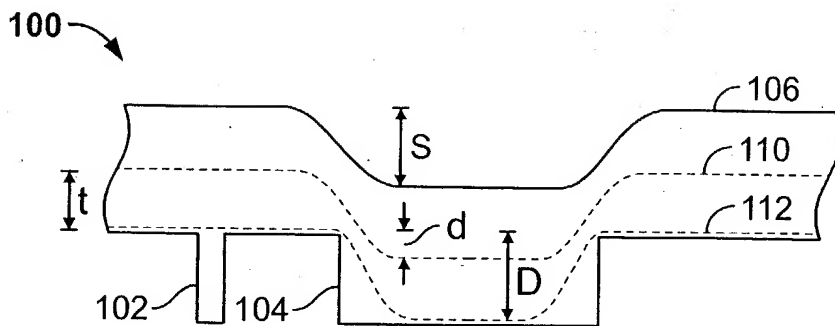


FIG. 1A

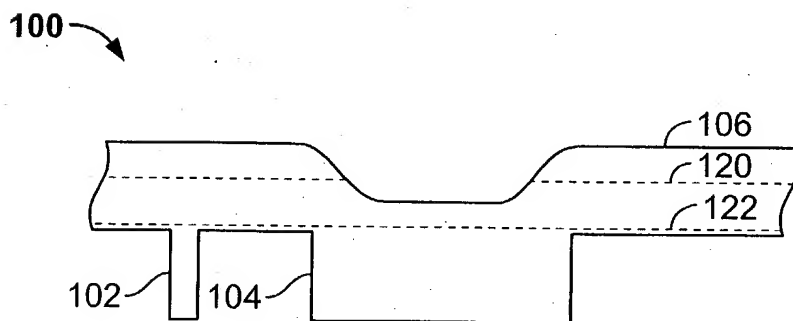


FIG. 1B

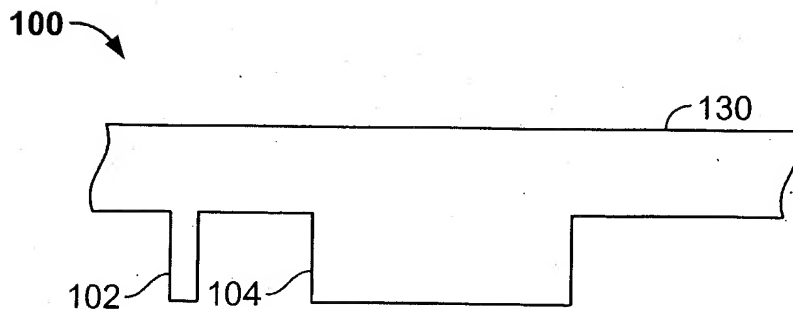


FIG. 1C

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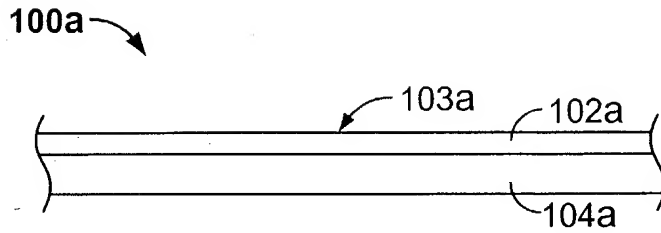


FIG. 2A

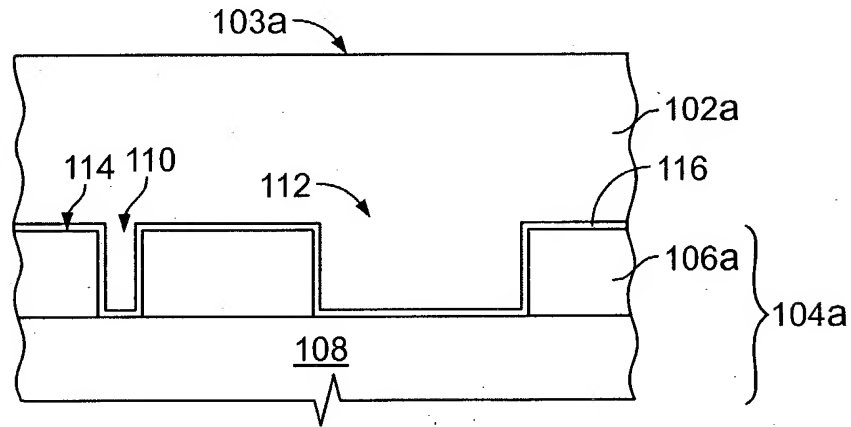


FIG. 2B

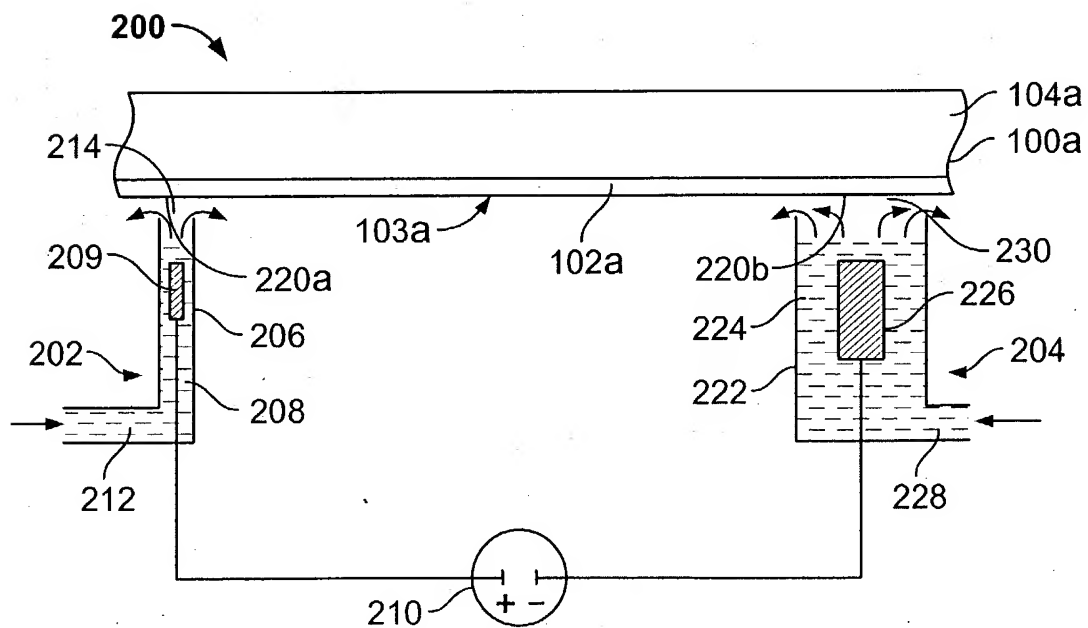


FIG. 3A

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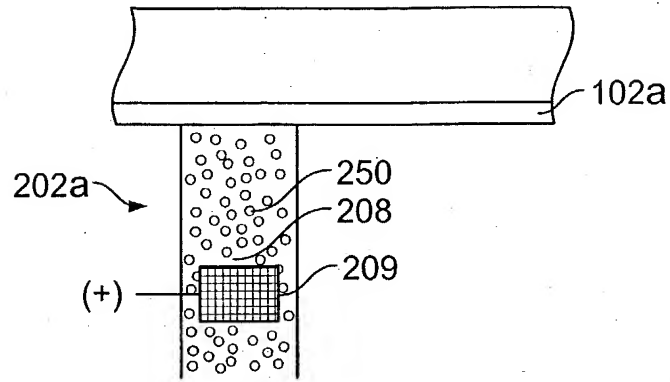


FIG. 3B

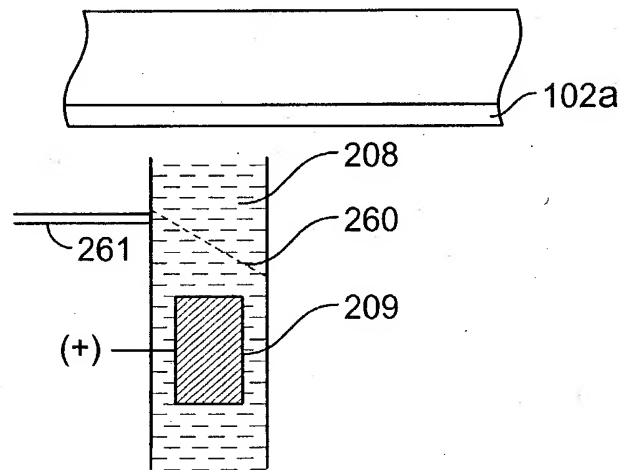


FIG. 3C

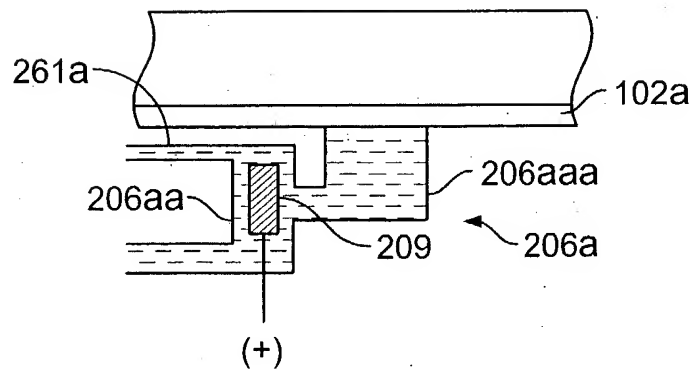


FIG. 3D

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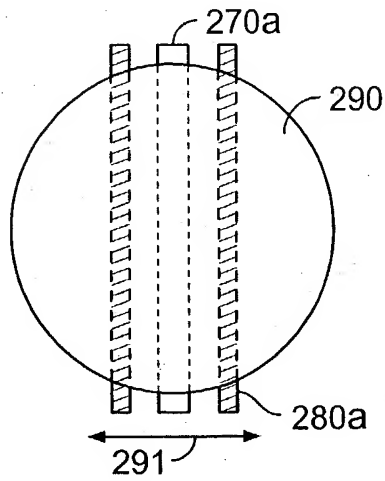


FIG. 3E

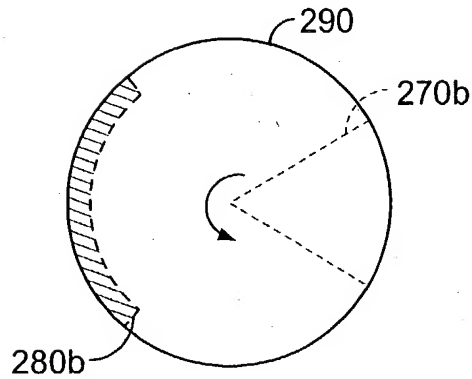


FIG. 3F

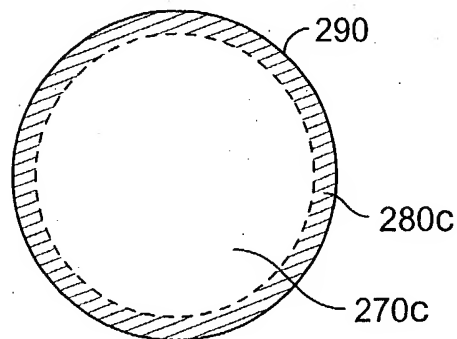


FIG. 3G

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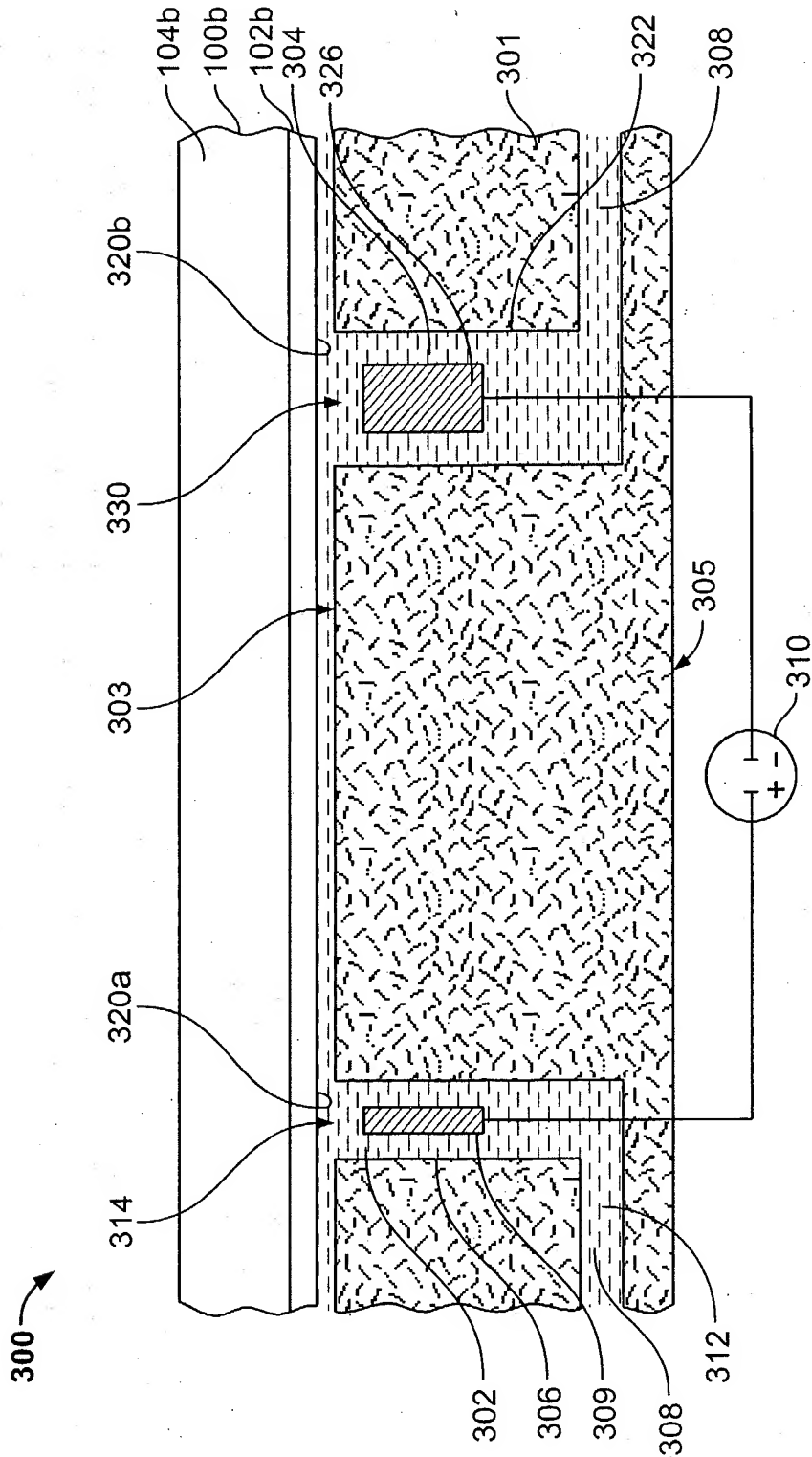


FIG. 4A

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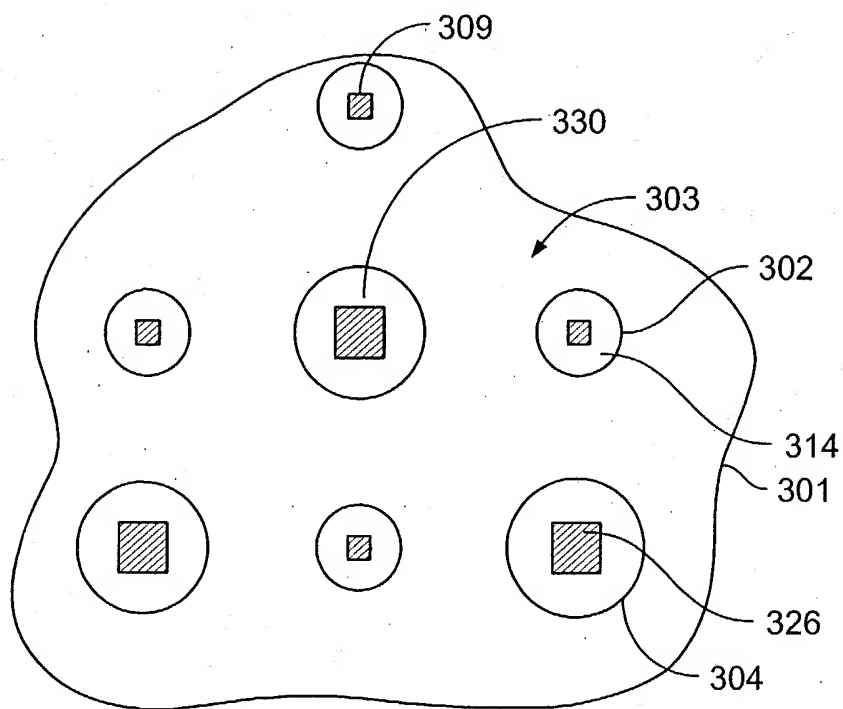


FIG. 4B

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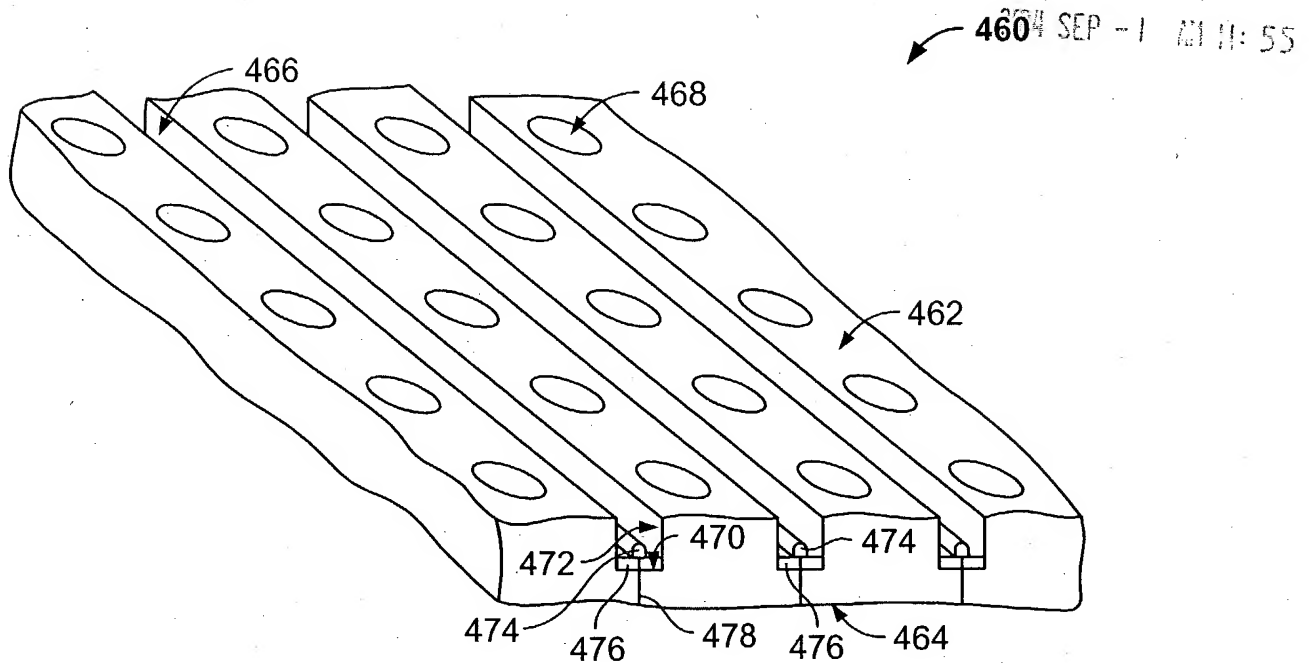


FIG. 6A

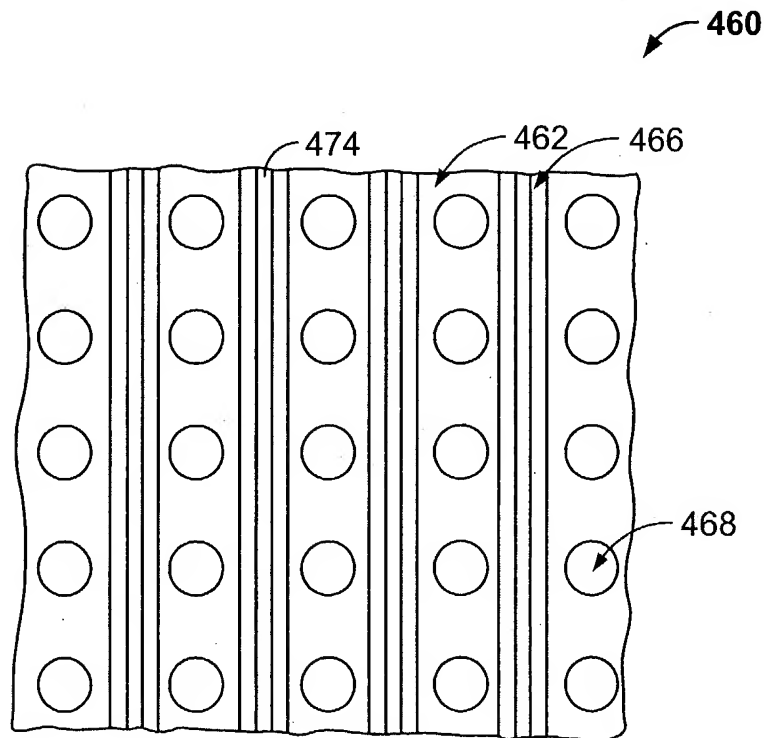


FIG. 6B

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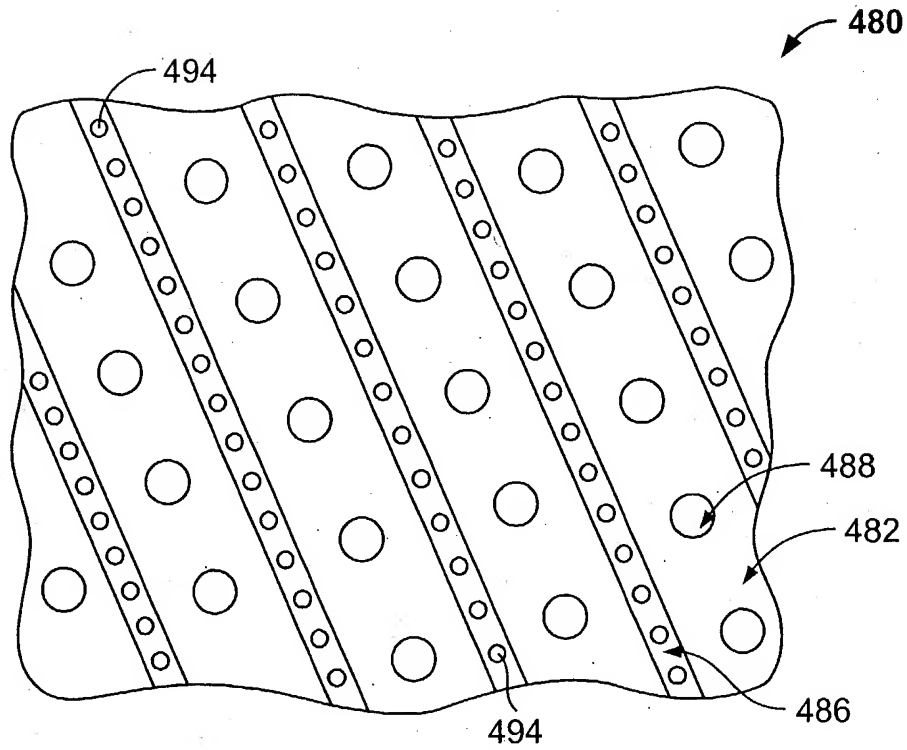


FIG. 7A

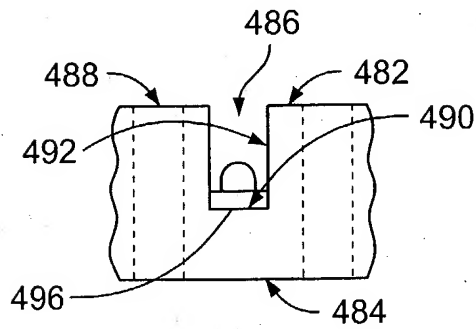


FIG. 7B

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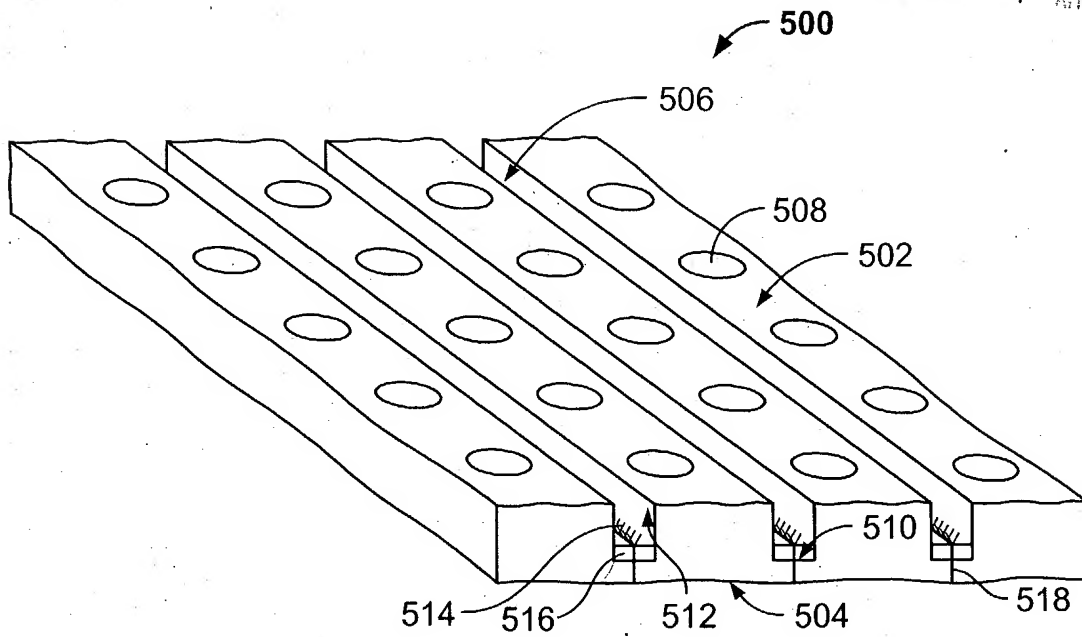


FIG. 8A

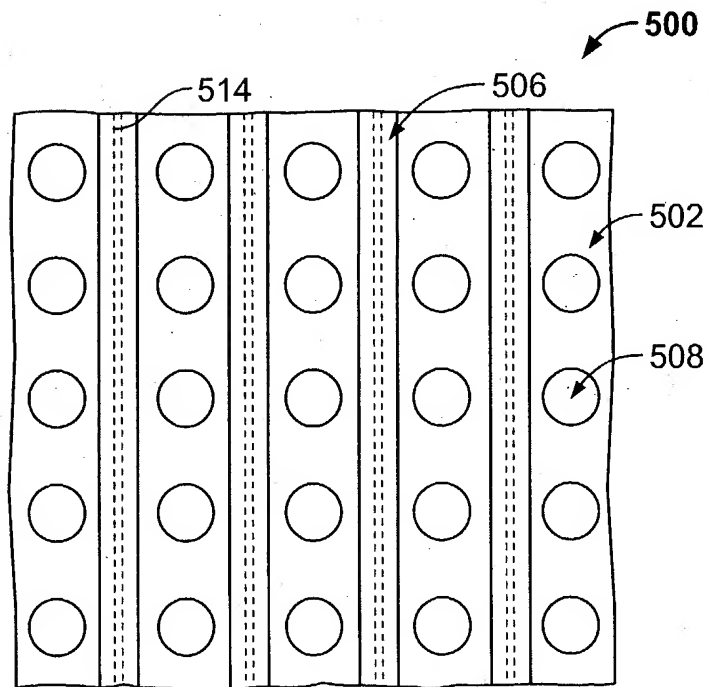


FIG. 8B

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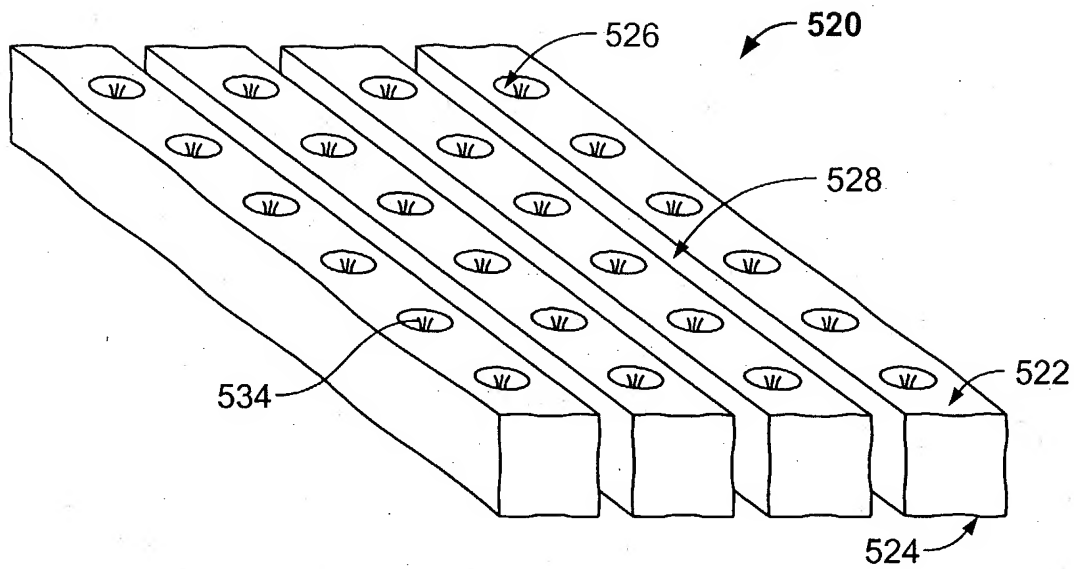


FIG. 9A

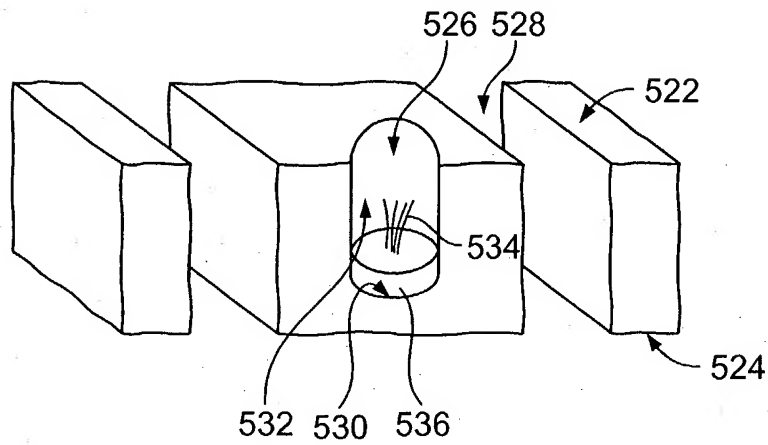


FIG. 9B

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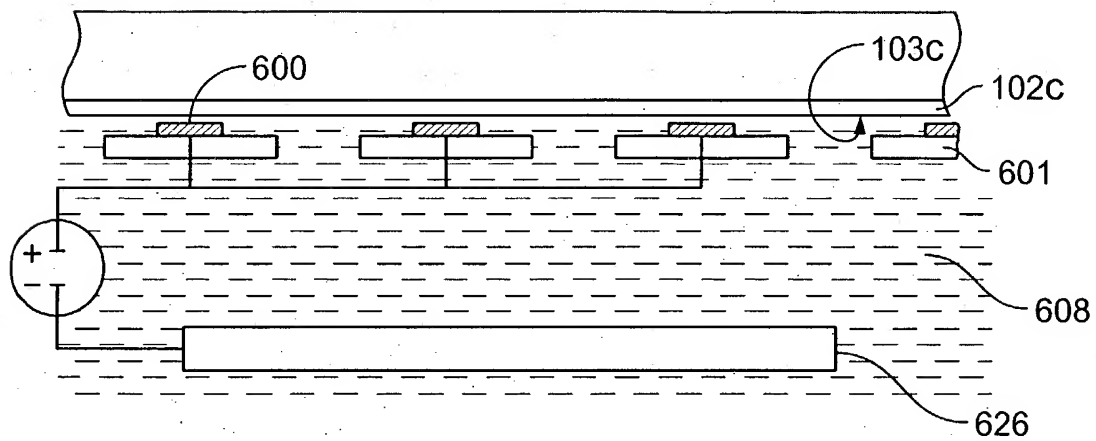


FIG. 10A

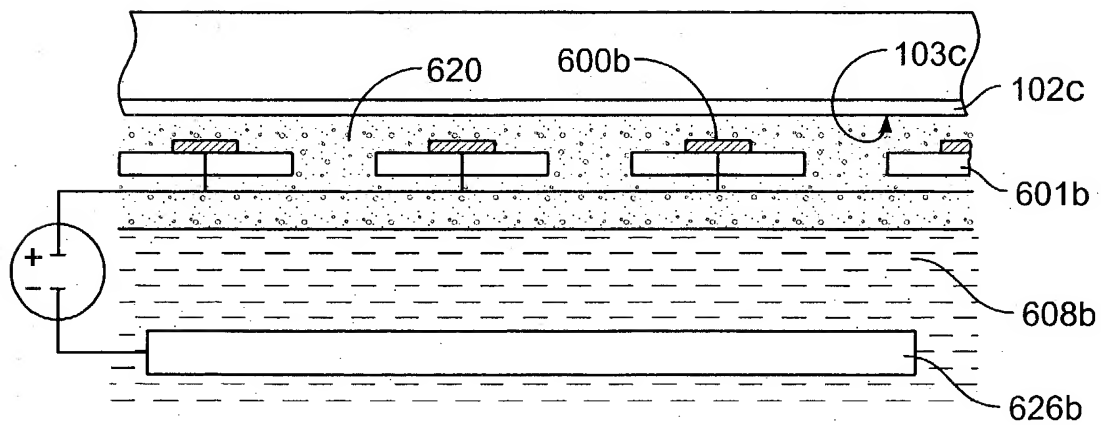
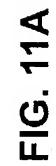
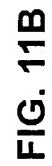


FIG. 10B

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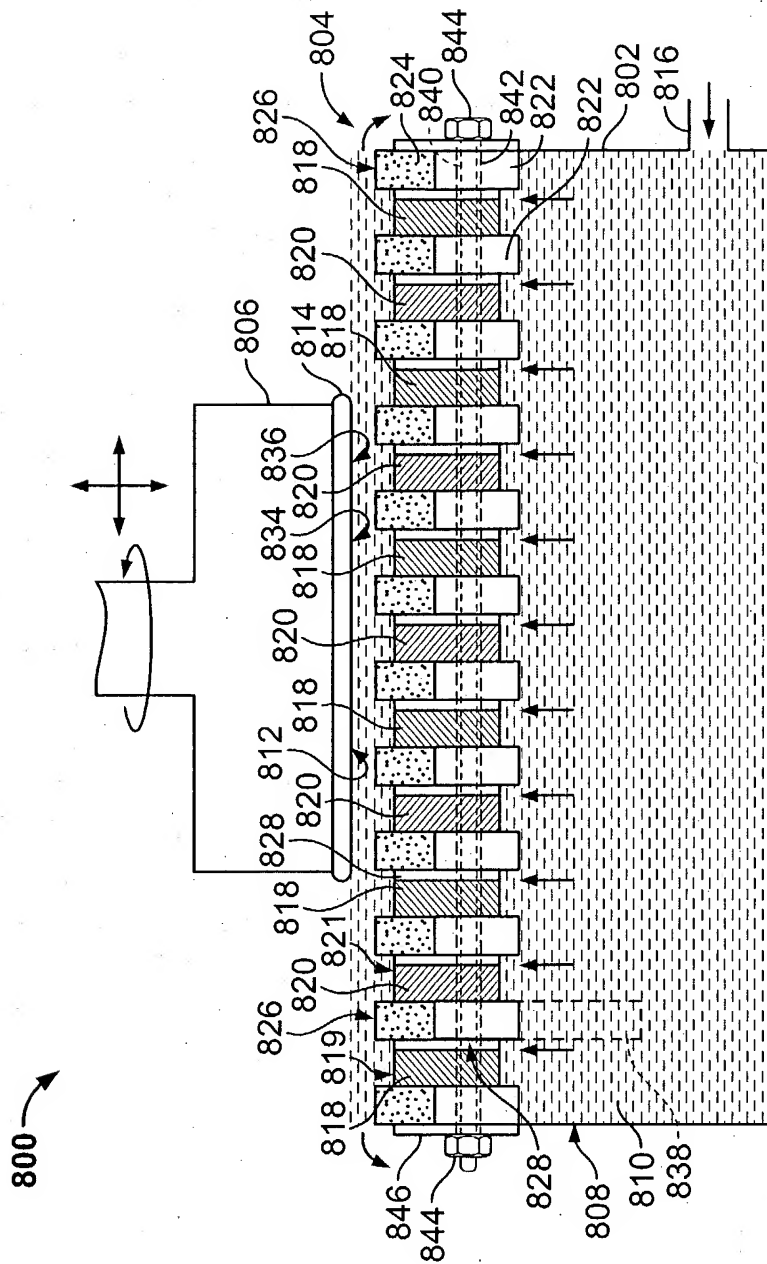


FIG. 12A

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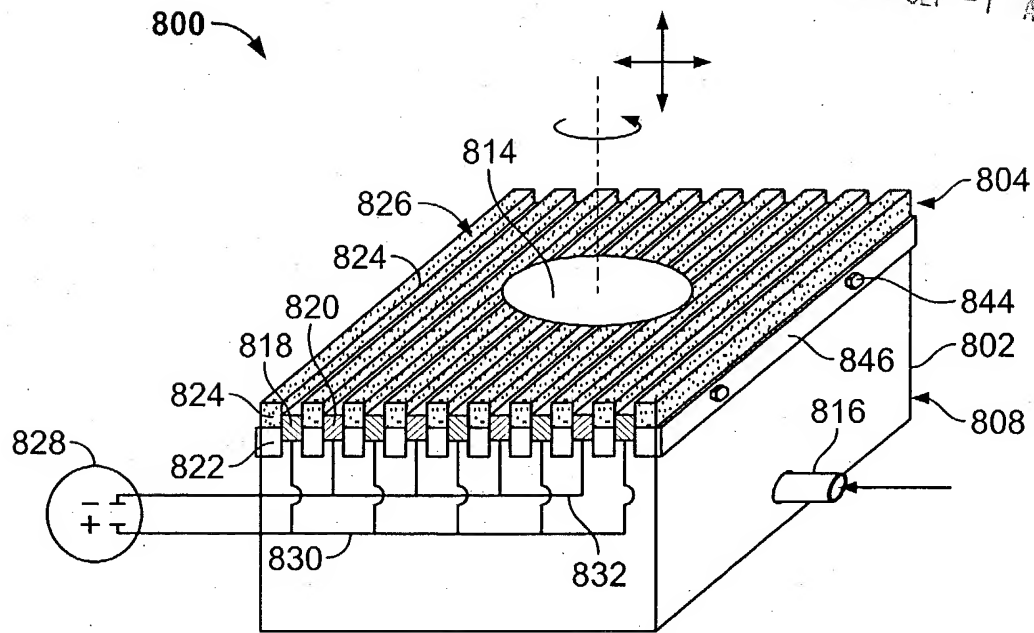


FIG. 12B

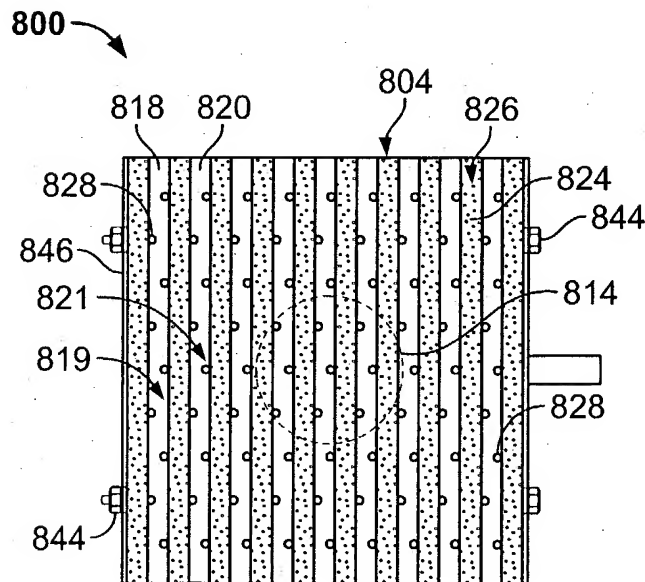


FIG. 12C

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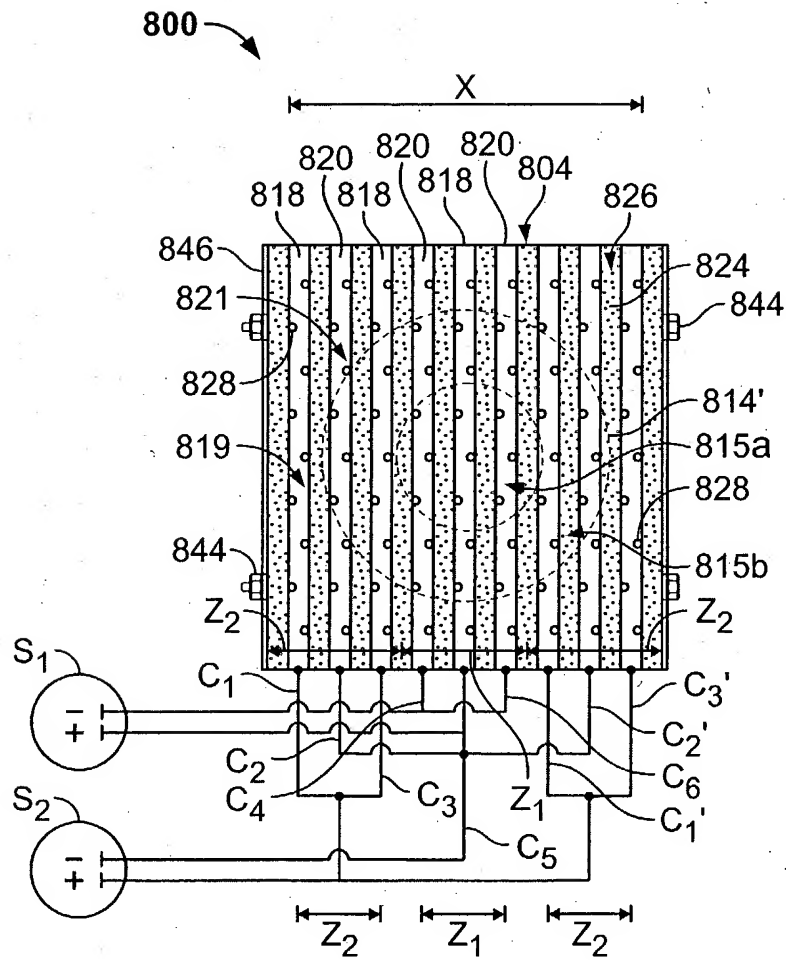


FIG. 13

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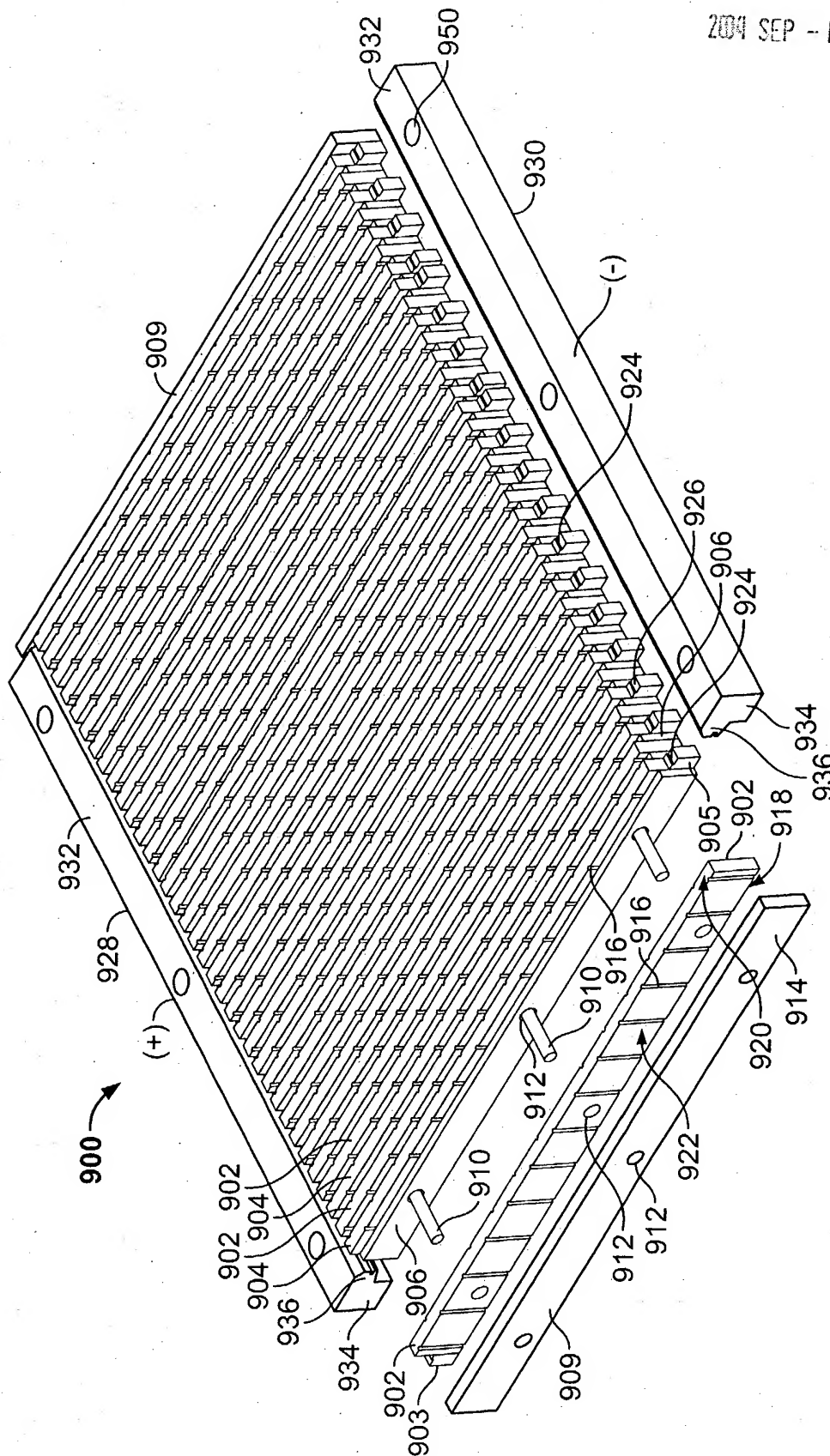


FIG. 14A

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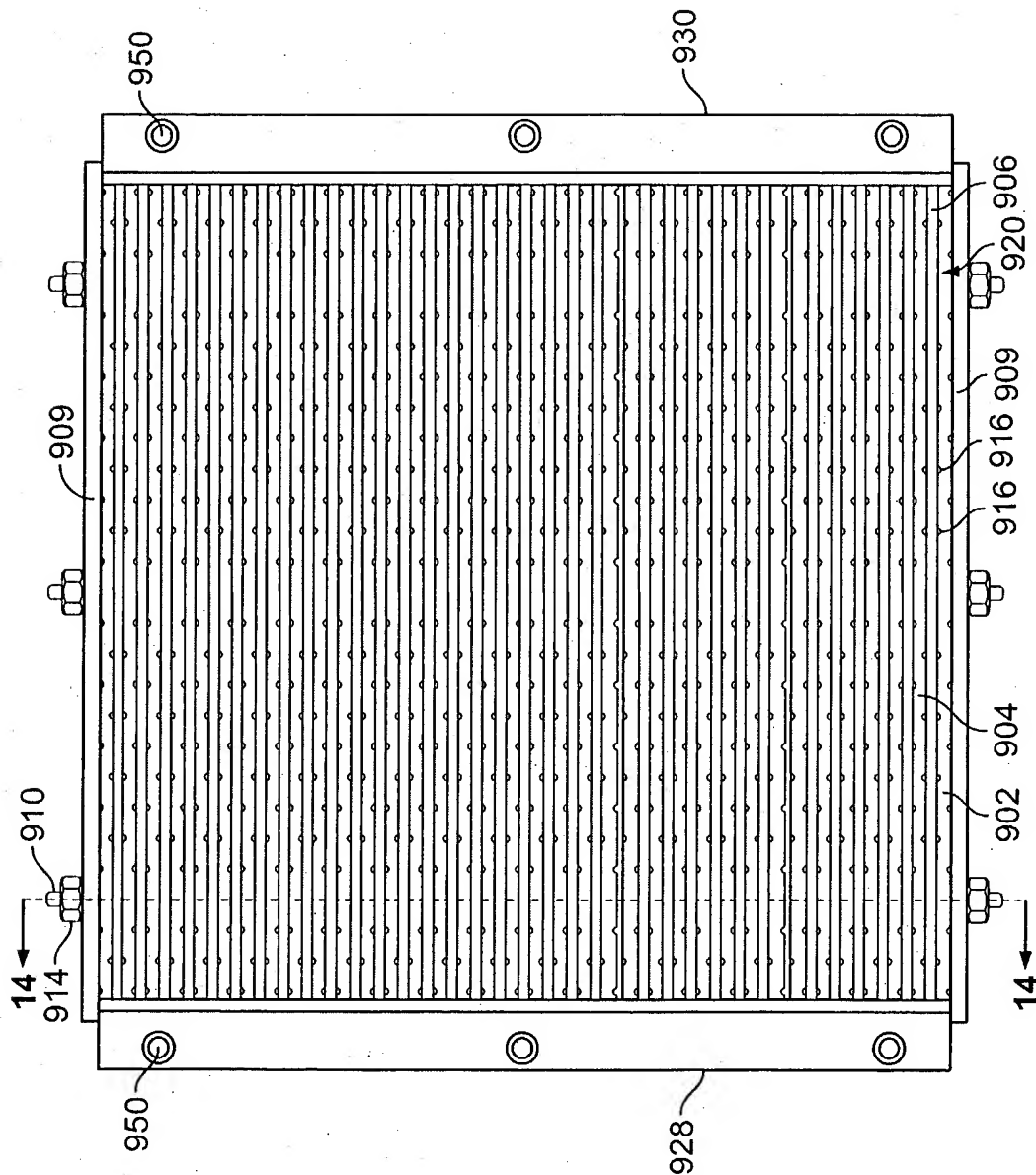
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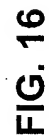
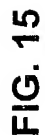
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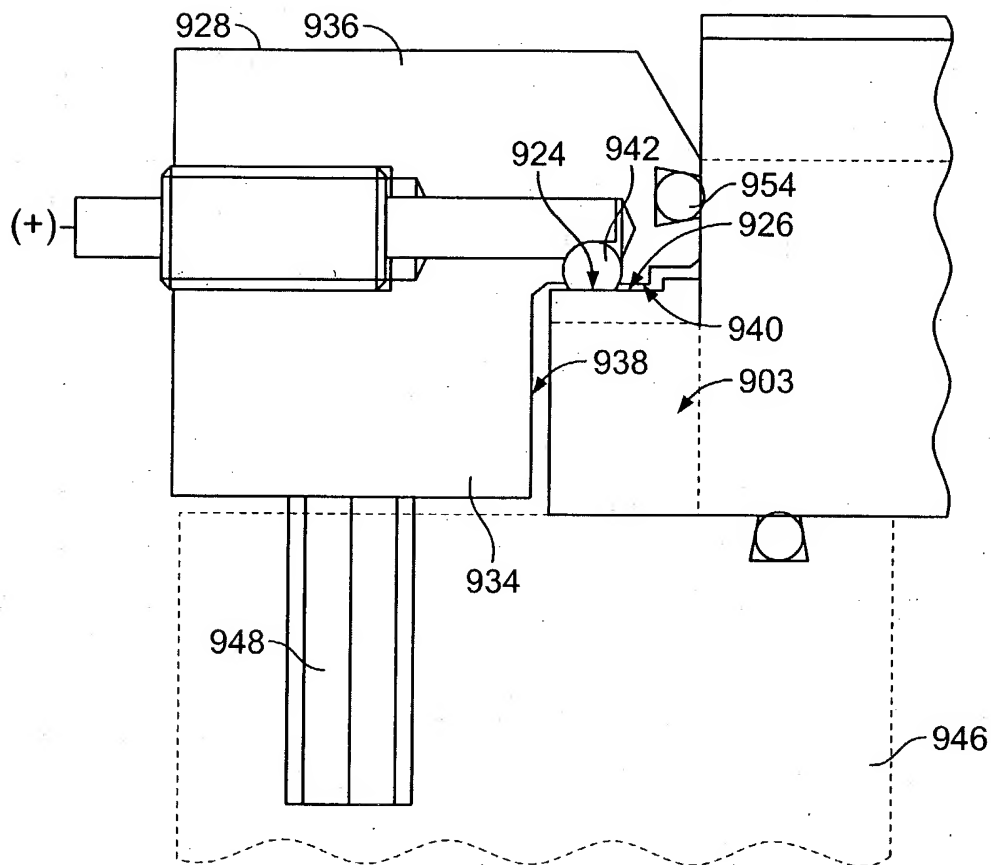


FIG. 17